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INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Applicant: Takayuki IKEDA et al.

Filing Date: April 4, 2000

Group:

U.S. PATENT DOCUMENTS

| Examiner Initial | Document Number | Date | Name | Class | Subclass | Filing Date (if appropriate) |
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| | Document Number | Date | Country | Class | Subclass | Translation Yes No |
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| | Furue et al., "P-78: Characteristics and Driving Scheme of Polymer-Stabilized Monostable FLCD Exhibiting Fast Response Time and High Contrast Ratio with Gray-Scale Capability", SID 98 Digest, ©1998, pp. 782-785 |
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Examiner

Ahmed N. Sefer

Date Considered

4-12-01

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